REPORT DOCUMENTATION PAGE		Form Approved OMB No. 0704-0188	
The public reporting burden for this collection of information is estimated to average 1 hour per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing the burden, to the Department of Defense, Executive Service Directorate (0704-0188). Respondents should be aware that notwithstanding any other provision of law, no person shall be subject to any penalty for failing to comply with a collection of information if it does not display a currently valid OMB control number. PLEASE DO NOT RETURN YOUR FORM TO THE ABOVE ORGANIZATION.			
1. REPORT DATE (DD-MM-YYYY) 2. REPORT TYPE 12-24-2010 Annual Progress 4. TITLE AND SUBTITLE 5a. CC Annual Progress Report for FA9550-08-1-0153 – YIP - Development of novel 5a. CC		3. DATES COVERED (From - To) 04/2008 - 11/2008	
		5a. CONTRACT NUMBER FA9550-08-1-0153	
and nanofabrication.	5b. GRANT NUMBER FA9550-08-1-0153		
		5c. PROGRAM ELEMENT NUMBER	
6. AUTHOR(S) 5d. Dr. Guido F. Verbeck, IV 5e. 5f. 7 5f. 7		5d. PROJECT NUMBER FA9550-08-1-0153	
		5e. TASK NUMBER N/A	
		RK UNIT NUMBER N/A	
 7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) University of North Texas 1155 Union Circle # 305250 Denton, TX 76203-5017 		8. PERFORMING ORGANIZATION REPORT NUMBER 6B783	
 9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES) AF Office of Scientific Research 875 N Randolph St. Suite 325, Room 3112 Arlington, VA 22203-1768 		10. SPONSOR/MONITOR'S ACRONYM(S) USAF, AFRL 11. SPONSOR/MONITOR'S REPORT NUMBER(S) AFRL-OSR-VA-TR-2012-0866	
12. DISTRIBUTION/AVAILABILITY STATEMENT Distribution A			
13. SUPPLEMENTARY NOTES N/A			
 14. ABSTRACT Two instruments have been developed to soft-land species with less than 10eV. First is the laser ablation-coupled drift tube. The chamber was developed with the idea of using an inert gas, helium, to thermalize ions. This allows us to reduce the clusters KE from 40 eV to about 1 eV by producing thermal collisions between the gas and our sample. The drift chamber was assembled using a 6" four-way cross coupled with a 6" reducing cross housing the ion drift cell. Nd-YAG 532nm was utilized to ionize the sample. The clusters formed were then discriminated by cross-section and transported through the drift cell with a potential from -100 to -500 V to our mica surface. The isolated sample was then characterized using AFM and electrochemistry. The second instrument is a rectilinear ion trap with integrated ultra fast pulse valve. This instrument has some novel electronics to allow complete shut-down of the applied RF in 2 cycles. This coupled to the high pressure acquisition makes it an ideal mass filter for preparative mass spectrometry. Though the ion current is an order of magnitude less than the drift tube, the resolution is 2 orders of magnitude greater, making the two instruments complimentary. 15. SUBJECT TERMS 			
Softlanding, Preparative Mass Spectrometry, Coatings			
16. SECURITY CLASSIFICATION OF: 17. LIMITATION OF a. REPORT b. ABSTRACT c. THIS PAGE 17. LIMITATION OF 18. NUMBER OF PAGES	19a. NAM Dr. Gui 19b. TFI	ME OF RESPONSIBLE PERSON ido F. Verbeck, IV EPHONE NUMBER (Include area code)	
U U U U 2		940-369-8423 Standard Form 298 (Rev. 8/08	

Annual Progress Report for FA9550-08-1-0158 – YIP - Development of novel preparative mass spectrometry instrumentation for the advancement of new materials and nanofabrication. (Year 2)

Dr. Guido Verbeck, University of North Texas, Denton, TX, USA.

Brief

A preparative material instrument utilizing Soft Landing Ion Mobility (SLIM) to deposit and comb through the various ionized species formed using front end chemistry (figure 1.) was developed in our lab. This novel instrument has allowed us to deposit selected ions onto unmodified substrates with kinetic energies (KE) ranging from 1 eV to sub-eV. The instrument is unique in that surfaces can be created at pressures spanning from 1 - 100 Torr rather than usual UHV conditions. This method with low kinetic energies allows the soft-landed ions to remain intact, retaining structure for self-assembly followed by the characterization of novel materials. Recently research in the field of carbon containing clusters and nanostructures have experienced a wealth of novel research and development about these complexes from diamond like coatings for wear resistant materials to semiconductor type material seen with graphene. We have investigated the deposition and surface characteristics of small carbon clusters (C_n , n = 1-5) formed from the laser ablation of bulk graphite.

Methods.

A graphite target used in these investigations was of high purity form and composed of 99.99% graphite. A pulsed 532 nm Nd:YAG laser ablates the graphite target in the presence of Helium gas which helps cool the sample and promote the formation of ionized clusters. Clusters formed during this event enter the drift tube and are separated based on the mobilities of the clusters. High mobility species (small molecules) exit the drift tube first followed by clusters with low mobilities. A unique pulsed ion optic at the end of drift tube allows for the selection of a specific cluster to be actively detected or deposited on our surface. This process then continues for each of the clusters present until we have created surfaces and combed through the entire drift spectrum. Characterization of these novel surfaces is done primarily with AFM and Raman spectroscopy, but other surface characterization techniques (SEM, XPS, LA-ICPMS) have been employed as well. The delivery force behind this specific softlanding technique is the drift tube where the ions are thermalized from 1eV to sub-eV kinetic energies via collisions with the buffer gas at



pressures between 1-10 Torr.

Carbon Deposition using Soft-landing Ion Mobility.

A drift tube spectra (Figure 2.) of carbon exhibited multiple peaks which corresponded to the small carbon clusters of C_n (n = 2-5). A broad peak that ranges from 4 – 7 ms is attributed to a ring structure and its corresponding conformers. The active soft-landing of C_2^+ on a mica substrate was carried out over 3 hours after deposition the sample was characterized using AFM and Raman. AFM images of the substrate showed a unique growth on the substrate where soft-landed C_2 clusters stacked on top of one another forming a multi-layer surface. This type of deposition can potentially be used for lubrication in MEMS fabricated devices (Figure 3). Soft-landing deposition of C^+ at1 Torr for 1hour and 10 mJ laser energy leads to the formation of an sp³ fibrous deposition on the



surface. This fibrous deposition was characterized using SEM as the deposition was too soft for contact and tapping modes of the AFM. SEM electron micrographs showed a network of interconnected sp³ hybridized carbon atoms linked to one another randomly. Raman spectroscopy of this fibrous material showed a highly disordered and amorphous nature of the sample. Depositing under different condition mainly adjusting the laser power <10 mJ a significant change in deposition was seen fibrous carbon was no longer deposited but instead a crystalline growth was seen on the surface Raman spectra showed that this deposition corresponded to an amorphous sp^3 type deposition similar to ta-C (diamond like carbon). Crystalline formations of the area were large and visible through a microscope subsequent AFM and SEM images were unsuccessful due to charge build up and size of the structures. Deposition of the of broad ring structure lead once again to build up of large structures visible optically through a microscope with the structure taking a graphitic shape. AFM images of the structure were unsuccessful but alternate SEM micrographs of the area showed the formation of small clusters and a buildup of particles on the surface. Raman spectroscopy verified the structure to be graphitic in nature as the structure had pronounced G characteristics with a peak 1585 cm^{-1} . The SLIM deposition of these novel materials (Figure 4) is a new and emerging field of stoichiometric controlled deposition through characterization and identification of these deposited materials we can begin to utilize these materials for real world applications.



